

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toshiyuki NAKAYAMA

Group Art Unit: 2815

Application No.: 09/582,351

Examiner: C. Chu

Filed: August 11, 2000

Docket No.: 106386

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURE THEREOF,
CIRCUIT BOARD AND ELECTRONIC INSTRUMENT

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**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

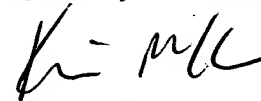
Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Applicant hereby request continued examination and entry and consideration of the June 26, 2002 submission under 37 C.F.R. §1.114. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 132932 in the amount of ☒ \$740.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Director is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,


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JAO:KMM/tam

Date: July 29, 2002

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